

	Type	L #	Hits	Search Text	DBs
1	BRS	L1	1653	substrate same (opening\$ same aperture\$3) same form\$3	USPAT
2	BRS	L2	225	1 and (dry same etch\$3)	USPAT
3	BRS	L3	2583	substrate same (opening\$ same aperture\$3) same form\$3	US- PGPUB; USPAT; EPO; JPO
4	BRS	L4	67273	3and (dry same etch\$3)	US- PGPUB; USPAT; EPO; JPO
5	BRS	L5	377	3 and (dry same etch\$3)	US- PGPUB; USPAT; EPO; JPO
6	BRS	L6	11	(laser same machining) and 5	US- PGPUB; USPAT; EPO; JPO
7	BRS	L7	169	(laser) and 5	US- PGPUB; USPAT; EPO; JPO